



Docket No.: T0461.70041US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Stefan Marinca et al.  
Serial No.: 10/680,265  
Confirmation No.: 6382  
Filed: October 7, 2003  
For: METHOD AND APPARATUS FOR COMPENSATING FOR  
TEMPERATURE DRIFT IN SEMICONDUCTOR PROCESSES AND  
CIRCUITRY  
Examiner: Y. Rossoshek  
Art Unit: 2825

Certificate of Mailing Under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: February 22, 2007

  
Steven J. Henry, Registration No. 27,900

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

**INTRODUCTORY COMMENTS**

In response to the Office Action dated September 6, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Drawings** begin on page 2 of this amendment.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.